## Amendments to the Claims:

Please amend the claims as follows (the changes in these claims are shown with strikethrough for deleted matter and <u>underlines</u> for added matter). A complete listing of the claims is listed below with proper claim identifiers.

## **Listing of Claims:**

(Currently Amended) A particle, comprising:
 a semiconductor nanocrystal,

wherein said nanocrystal is doped with a carrier selected from the group consisting of an electron and a hele, such that the electron carrier is in a quantum confined state at room temperature and in the absence of an applied electric potential.

- 2. (Original) The particle of claim 1, wherein said nanocrystal is n-doped.
- 3. (Cancelled)
- 4. (Original) The particle of claim 2, wherein said nanocrystal comprises a 2-6 semiconductor compound.
- 5. (Original) The particle of claim 4, wherein said nanocrystal is selected from the group consisting of zinc oxide, cadmium sulfide and cadmium selenide.
  - 6. (Original) A colloid, comprising a plurality of the particles of claim 1.
  - 7. (Original) A film, comprising a plurality of the particles of claim 1.
- 8. (Original) The particle of claim 1, further comprising capping groups, on the surface of said nanocrystal.
  - 9. (Original) A film, comprising a plurality of the particles of claim 4.

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10. (Currently Amended) A method of making a particle, comprising:
adding at least one electron carrier to a semiconductor nanocrystal, to
form a doped semiconductor nanocrystal;

wherein said earrier is selected from the group consisting of an electron and a hole, and said earrier is in a quantum confined state at room temperature and in the absence of an applied electric potential.

- 11. (Currently Amended) The method of claim 10, wherein said adding comprises contacting said semiconductor nanocrystal with <u>a</u> an oxidizing or reducing agent.
- 12. (Currently Amended) The method of claim 10, wherein said adding comprises exidizing or reducing electrochemically.

## 13-14. (Cancelled)

- 15. (Currently Amended) The method of claim <u>10</u> <del>13</del>, wherein said nanocrystal comprises a 2-6 semiconductor compound.
- 16. (Original) The method of claim 15, wherein said nanocrystal is selected from the group consisting of zinc oxide, cadmium sulfide and cadmium selenide.
- 17. (Original) A method of making a colloid, comprising making a plurality of the particles by the method of claim 10.
  - 18. (Original) A method of making a film, comprising: forming a colloid by the method of claim 17, and applying said colloid to a surface.
- 19. (Previously presented) The method of claim 10, wherein said particle comprises capping groups, on the surface of said nanocrystal.
- 20. (Original) The method of claim 11, wherein said semiconductor nanocrystal is in a film comprising a plurality of semiconductor nanocrystals.

- 21. (Original) A product, prepared by the method of claim 10.
- 22. (Original) A product, prepared by the method of claim 11.
- 23. (Original) A product, prepared by the method of claim 12.
- 24. (Currently Amended) A product, prepared by the method of claim 15 43.
- 25. (Original) A product, prepared by the method of claim 17.
- 26. (Original) A product, prepared by the method of claim 18.
- 27. (Original) A product, prepared by the method of claim 20.
- 28. (Original) A display, comprising a plurality of the particles of claim 1.
- 29. (Original) An opto-electronic device, comprising a plurality of the particles of claim 1.
- 30. (Original) The opto-electronic device of claim 29, wherein said device is a memory array.
- 31. (Original) A method of making an object appear cooler or warmer to an IR detector, comprising coating said object with a plurality of the particles of claim 1.
  - 32. (Original) An n-p junction, comprising a plurality of the particles of claim 1.
- 33. (Original) The n-p junction of claim 32, further comprising a polymer electrolyte.
  - 34-35. (Cancelled)
- 36. (Previously presented) The particle of claim 5, further comprising trioctylphosphine oxide capping groups on a surface of said nanocrystal.
- 37. (Previously presented) The particle of claim 8, wherein said capping groups comprise trioctylphosphine oxide.

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- 38. (Previously presented) The method of claim 10, wherein said adding comprises contacting said semiconductor nanocrystal with a reducing agent, said reducing agent comprising sodium.
- 39. (Previously presented) The method of claim 38, wherein said reducing agent comprises sodium biphenyl.
- 40. (Previously presented) The method of claim 11, wherein said adding further comprises contacting said semiconductor nanocrystal with a charge shuttle.
- 41. (Previously presented) The method of claim 16, wherein said adding comprises contacting said semiconductor nanocrystal with a reducing agent, said reducing agent comprising sodium.
- 42. (Previously presented) The method of claim 41, wherein said reducing agent comprises sodium biphenyl.